EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	"20020086164"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/08 07:13
L33	10	"6316110"	USPAT	OR	OFF	2008/07/08 07:35
L34	1	"10562121"	US-PGPUB; USPAT	OR	OFF	2008/07/08 08:37
L35	70	(ZnO or (zinc adj oxide $2)) same (increas$4 adj crystal$8)	US-PGPUB; USPAT	OR	OFF	2008/07/08 08:38
L36	1	"20020086164"	US-PGPUB; USPAT	OR	OFF	2008/07/08 09:30
L37	1	"20020139772"	US-PGPUB; USPAT	OR	OFF	2008/07/08 09:30
S1	10066306	(substrate$2 or base$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:56
S2	324224	S1 and (dielectric$2 same (coat$5 or film$2 or layer $5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:56
S3	73348	S2 and (sputter$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:57
S4	18646	S2 and ((sputter$4) same ((nitrogen or N) or (oxygen or "O.sub.2")))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:57
S5	18353	S2 and ((sputter$4) same ((nitrogen or N) or (oxygen or O)))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:58
S6	3190	S5 and (ion$2 same beam $2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:58
S7	94	S6 and ((dielectric$2 same (coat$5 or film$2 or layer$5)) same crystallize $2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 12:59
S8	37	S7 and @PY<"2004"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/04/16 13:00
S9	6	"5814392"	USPAT	OR	OFF	2008/04/17 08:00
S10	14	"5877555"	USPAT	OR	OFF	2008/04/17 08:08
S11	11	"5960251"	USPAT	OR	OFF	2008/04/17 08:10

S12	23	"5548475"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 07:34
S13	233	((dielectric$2) same (ion adj beam)) same (crystal $9)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 07:46
S14	116	S13 and @PY<"2004"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 07:47
S15	1	"10562121"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 09:16
S16	2	"20050209084"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 10:19
S17	284338	(substrate$2) and (dielectric same (layer$4 or coat$5 or film$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 14:56
S18	20986	S17 and ((zinc same oxide $2) or ZnO)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 14:58
S19	8719	S18 and (SiN or (silicon adj nitride$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 14:59
S20	7030	S19 and (semiconductor $2 or transistor$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 14:59
S21	1336	S20 and (crystallinit$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:00
S22	907	S21 and ((silver or Ag) same (layer$4 or film$2 or coat$5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:01
S23	255	S22 and (alternat$4 same (layer$4 or film42 or coat $5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:01
S24	5	S23 and glazing	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:01
S25	3754	S20 and (((silver or Ag) same (layer$4 or film$2 or coat$5)))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:06
S26	1368	S25 and (alternat$4 same (layer$4 or film42 or coat $5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:06
S27	28	S26 and glazing$2	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:06
S28	200	S23 and (surface same resist$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/03 15:10

S29	10238	(substrate$2 or base$2) and ((znO or (zinc same oxide$2)) same (coat$5 or layer$5 or film$2)) and capacitor$2	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:29
S30	1078	S29 and (refractive adj index$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:29
S31	37	S30 and (thin same film).ti.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:30
S32	22	S31 and (SiN or (silicon adj nitride$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:35
S33	2	S32 and crystalline	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:35
S34	2	S32 and crystallin$6	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:35
S35	21	S32 and crystal$10	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:36
S36	17236	(substrate$2 or base$2) and ((znO or (zinc same oxide$2)) same (coat$5 or layer$5 or film$2)) and (capacitor$2 or transistor $2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:44
S37	14874	S36 and ((ZnO or (zinc adj oxide$2)) same (layer $5 or coat$5 or film$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:45
S38	1714	S37 and (thin same film).ti.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:45
S39	1076	S38 and ((SiN or (silicon adj nitride$2)) same (film $2 or coat$5 or layer$5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:46
S40	0	S39 and (refract same (index$2 or indic$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:46
S41	34	S39 and (refract$5 same (index$2 or indic$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:46
S42	55	S38 and (refract$5 same (index$3 or indic$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 06:53
S43	156486	(thin same film$2).ti.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:06

S44	61892	S43 and (capacitor$2 or semiconductor$2 or transistor$2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:06
S45	2775	S44 and ((ZnO or (zinc same oxide$2)) same (coat$5 or layer$5 or film $2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:07
S46	202	S44 and (((ZnO or (zinc same oxide$2)) same (coat$5 or layer$5 or film $2)) same (("Si.sub.3.N. sub.4" or (silicon adj nitride$2)) same (coat$5 or film$2 or layer$5)))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:09
S47	41	S46 and @PY<"2004"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:09
S48	3	S46 and ((ZnO or (zinc adj oxide$2)) same (ferroelectric$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:28
S49	47	S46 and ((ZnO or (zinc adj oxide$2)) same (dielectric$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:41
S50	3	S46 and ((ZnO or (zinc adj oxide$2)) same (wave same guide$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 07:53
S51	4	S46 and ((ZnO or (zinc adj oxide$2)) same (PZT))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:00
S52	37038	(substrate$2) and ((thin adj film$2) same dielectric $2)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:34
S53	15892	S52 and sputter$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:34
S54	10154	S53 and crystal$10	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:34
S55	7729	S54 and (("SiO.sub.2" or silica or (silicon adj $3oxide$2)) same (layer $5 or film$2 or coat$5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:35
S56	1171	S55 and ((ZnO or (zinc adj oxide$2)) same (layer $5 or film42 or coat$5))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:36
S57	670	S56 and ("Si.sub.3.N. sub.4." or (silicon adj nitride$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:37
S58	420	S57 and ((silver or Ag) same (layer$5 or coat$5 or film$2))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:38

S59	125	S58 and (refract$7 same (index$3 or indic$3))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:38
S60	50	S59 and @PY<"2004"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:38
S61	1	"10562121"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 08:59
S62	57	(window adj glass) same (glaz$4 same laminat$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 11:31
S63	14	S62 and (electromagnetic)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/07/07 11:33

7/8/2008 9:30:45 AM
C:\ Documents and Settings\ lrobinson2\ My Documents\ EAST\ Workspaces\ 10562121.wsp